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| APPLICATION NUMBER | FILING OR 371(c) DATE | FIRST NAMED APPLICANT | ATTY. DOCKET NO./TITLE |
|--------------------|-----------------------|-----------------------|-------------------------|
| 10/561,821 | 02/07/2007 | Sakae Koyata | JG-SU-5221/500577.20071 |

CONFIRMATION NO. 2851

26418
REED SMITH, LLP
ATTN: PATENT RECORDS DEPARTMENT
599 LEXINGTON AVENUE, 29TH FLOOR
NEW YORK, NY 10022-7650

Title: Processing Method of Silicon Wafer

Publication No. US-2007-0267387-A1

Publication Date: 11/22/2007

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